

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyoshi TOMINAGA et al.

Application No.: New U.S. National Stage of
PCT/JP03/03743

Filed: June 29, 2004

Docket No.: 120214

For: WAFER DOUBLE-SIDE POLISHING APPARATUS AND DOUBLE-SIDE POLISHING
METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of the non-English language reference 7 is discussed in the present specification.
- ☒ 3. The references 1-7 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.
- ☒ 4. English-language Abstracts of the non-English language references 1-7 are attached hereto.

10/500278

DT04 Rec'd PCT/PTO 29 JUN 2004

- ☒ 5. A computer-generated English translation of the following Japanese references has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 1-7.

Respectfully submitted,



William P. Berridge
Registration No. 30,024

Thomas J. Pardini
Registration No. 30,411

WPB:TJP/mlo

Date: June 29, 2004

OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

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Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 120214		APPLICATION NO. New U.S. National Stage of PCT/JP03/03743 10/500278	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Hiroyoshi TOMINAGA et al.			
				FILING DATE June 29, 2004		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	1.	JP A 7-111255 w/abstract & transl.	4/25/1995	JAPAN			
	2.	JP A 2001-30151 w/abstract & transl.	2/6/2001	JAPAN			
	3.	JP A 2002-46059 w/abstract & transl.	2/12/2002	JAPAN			
	4.	JP A 9-262759 w/abstract & transl.	10/7/1997	JAPAN			
	5.	JP A 10-249717 w/abstract & transl.	9/22/1998	JAPAN			
	6.	JP A 2001-252864 w/abstract & transl.	9/18/2001	JAPAN			
	7.	JP A 10-202511 w/abstract & transl.	8/4/1998	JAPAN			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER				DATE CONSIDERED			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: June 29, 2004